



Inventor: Gurtej S. Sandhu, et al.

Title: Deposition Methods and Apparatuses Providing Surface Activation

Assignee: Micron Technology, Inc.

Serial No.: 09/652,533

Filing Date: August 31, 2000

Docket No. MI22-1385

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Suppl
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J. McMillan
12/17/02
RECEIVED
DEC -9 2002
TC 2800 MAIL ROOM

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether any of the submitted references is prior art. Copies of the references are attached.

Citation of this reference is respectfully requested.

Respectfully submitted,

Dated: 04 Dec 2002

Attorney: 

James E. Lake
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